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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Confirmation No.: 6765

KOKUBUN et al.

Examiner: John M. Hoffmann

Serial No: 10/649,695

Group Art Unit: 1731

Filed: August 28, 2003

For:

OPTICAL WAVEGUIDE AND METHOD OF MANUFACTURING THE SAME

COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(c)

Sir:

A copy of a Japanese Office Action mailed May 23, 2006 in connection with Japanese application 2002-275675, believed to correspond to the captioned application, is enclosed along with copies of the references cited therein. Also enclosed are English abstracts for the three Japanese language documents.

On information and belief, each item of information contained in this Information Disclosure Statement was first cited in any communication received from a foreign patent office in a counterpart foreign application not more than three months prior to today's (June 19, 2006) filing of this Information Disclosure Statement.

Respectfully submitted,

BACON & THOMAS

Date: June 19, 2006

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Filing Date

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U.S. Patent Documents

Examiner Initial	Document Number	Date	Patentee/Applicant	Class	Subclass	Filing Date if Appropriate
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Foreign Patent Documents

Examiner Initial	Document Number	Publication Date	Country/Agency	Class	Subclass	Translation	
						Yes	No
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Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

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<u> </u>		
Examiner	Date Considered	

EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.